

Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 13549
Application ID: 09683533
Title of Invention: SYSTEMS AND METHODS FOR
THERMAL ISOLATION OF A
SILICON STRUCTURE
First Named Inventor: Joel KUBBY
Domestic/Foreign Application: Domestic Application
Filing Date: null
Effective Receipt Date: 2002-01-16
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation Number: 0
Attorney Docket Number: 111014
Digital Certificate Holder: cn=Thomas J. Pardini, ou=Registered Attorneys, ou=Patent and
Trademark Office, ou=Department of Commerce, o=U.S.
Government, c=US
Certificate Message Digest: xBMdlq8NLJllwCSVDVxwtg==
Total Fees Authorized: \$780.0
Payment Category: DA - Deposit Account
Deposit Account Number: 240037
Deposit Account Name: Thomas J. Pardini



2002-01-16 11:10:14

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 111014

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: SYSTEMS AND METHODS FOR THERMAL ISOLATION OF A SILICON
STRUCTURE

Suggested Representative Figure: 2

Customer Number Attorney: 27074



Customer Number Correspondence Address: 27074



INVENTOR(s):

Primary Citizenship: USA

Given Name: Joel

Middle Name: A.

Family Name: KUBBY

Residence City: Rochester

Residence State: New York

Residence Country: US

Address: 63 Spring Valley Drive
Rochester New York, 14622 US

2010-01-16 09:10:00